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Receipt  
PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

#3  
J

First Named Applicant: Jammy et al.  
Application No.: 09/363,523  
Filed: July 29, 1999

Docket No.: 99 P 7722 US  
Group Art Unit: 2811  
Examiner: Not Assigned  
Date: November 10, 1999

Title: Method For Forming Crystalline Silicon Nitride

Attn: Customer Correction Branch  
Application Processing Division

Hon. Assistant Commissioner for Patents  
Washington, DC 20231

REQUEST FOR CORRECTION OF FILING RECEIPT

Sir:

The Filing Receipt in the above referenced matter contains a typographical error. Enclosed (Exhibit A) is a copy of the Express Mailing Label in the above matter, on which the date of deposit is shown to be **July 29, 1999**. The Filing Receipt, however, states the filing date incorrectly as **July 28, 1999**. The **boldface** text shows the location of the typographical error.

Enclosed (Exhibit B) is a copy of the Filing Receipt upon which the necessary changes have been noted.

Issuance of a corrected Filing Receipt is respectfully solicited. It is believed that no fee is due for this Request. However, if such a fee is due, please charge it to Deposit Account No. 19-2179.

Respectfully submitted,

*Donald B. Paschburg*

Donald B. Paschburg, Esq.  
Reg. No. 33,753

Dated: November 10, 1999

Siemens Corporation  
Intellectual Property Department  
186 Wood Avenue South  
Iselin, New Jersey 08830  
(732) 321-3191

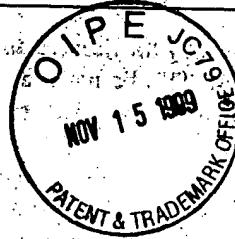
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NOV 29 1999  
REG. MAIL ROOM

FILING RECEIPT

UNITED STATES DEPARTMENT OF COMMERCE  
Patent and Trademark Office  
ASSISTANT SECRETARY AND COMMISSIONER  
OF PATENTS AND TRADEMARKS  
Washington, D.C. 20231

APPLICATION NUMBER	FILING DATE	GRP ART UNIT	FIL FEE REC'D	ATTORNEY DOCKET NO.	DRWGS	TOT CL	IND CL
09/363,523	07/28/99	2811	\$760.00	99-P-7722-US	5	20	3

SIEMENS CORPORATION  
INTELLECTUAL PROPERTY DEPARTMENT  
186 WOOD AVENUE SOUTH  
ISELIN NJ 08830



Receipt is acknowledged of this nonprovisional Patent Application. It will be considered in its order and you will be notified as to the results of the examination. Be sure to provide the U.S. APPLICATION NUMBER, FILING DATE, NAME OF APPLICANT, and TITLE OF INVENTION when inquiring about this application. Fees transmitted by check or draft are subject to collection. Please verify the accuracy of the data presented on this receipt. If an error is noted on this Filing Receipt, please write to the Office of Initial Patent Examination's Customer Service Center. Please provide a copy of this Filing Receipt with the changes noted thereon. If you received a "Notice to File Missing Parts of Application" ("Missing Parts Notice") in this application, please submit any corrections to this Filing Receipt with your reply to the "Missing Parts Notice." When the PTO processes the reply to the "Missing Parts Notice," the PTO will generate another Filing Receipt incorporating the requested corrections (if appropriate).

Applicant(s) RAJARAO JAMMY, WAPPINGERS FALLS, NY; PHILIP L. FLAITZ, NEWBURGH, NY; PHILIP E. BATSON, KATONAH, NY; HUA SHEN, BEACON, NY; YUN YU WANG, POUGHQUAG, NY.

IF REQUIRED, FOREIGN FILING LICENSE GRANTED 08/25/99  
TITLE

METHOD FOR FORMING CRYSTALLINE SILICON NITRIDE

PRELIMINARY CLASS: 257

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TC 2800 MAIL ROOM

(Exhibit B)

DATA ENTRY BY: GARNETT, SANDRA TEAM: 06 DATE: 08/25/99



(See reverse for more information)

FILE COPY 6

SERIAL NUMBER 09/363,523	FILING DATE 07/29/99	CLASS 257	GROUP ART UNIT 2815	ATTORNEY DOCKET NO. 99-P-7722-US
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APPLICANT  
RAJARAO JAMMY, WAPPINGERS FALLS, NY; PHILIP L. FLAITZ, NEWBURGH, NY;  
PHILIP E. BATSON, KATONAH, NY; HUA SHEN, BEACON, NY; YUN YU WANG,  
POUGHQUAG, NY.

\*\*CONTINUING DOMESTIC DATA\*\*\*\*\*

VERIFIED

EO None

\*\*371 (NAT'L STAGE) DATA\*\*\*\*\*

VERIFIED

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\*\*FOREIGN APPLICATIONS\*\*\*\*\*

VERIFIED

EO None

IF REQUIRED, FOREIGN FILING LICENSE GRANTED 08/25/99

Foreign Priority claimed 35 USC 119 (a-d) conditions met	<input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> Met after Allowance	STATE OR COUNTRY NY	SHEETS DRAWING 5	TOTAL CLAIMS 20	INDEPENDENT CLAIMS 3
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Verified and Acknowledged Examiner's Initials <u>EO</u>	Initials _____
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ADDRESS SIEMENS CORPORATION INTELLECTUAL PROPERTY DEPARTMENT 186 WOOD AVENUE SOUTH ISELIN NJ 08830
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TITLE METHOD FOR FORMING CRYSTALLINE SILICON NITRIDE
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FILING FEE RECEIVED \$760	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT NO. _____ for the following:	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit
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